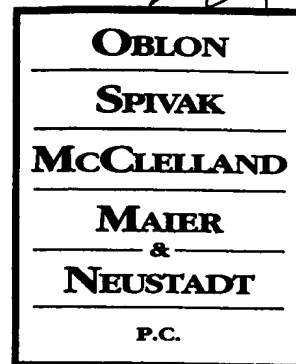




Docket No.: 205890US99



ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

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RE: Application Serial No.: 09/721,566
Applicants: Jamal RAMDANI et al.
Filing Date: NOVEMBER 22, 2000
For: STRUCTURE AND METHOD FOR FABRICATING
SEMICONDUCTOR STRUCTURES AND DEVICES UTILIZING
THE FORMATION OF A COMPLIANT SUBSTRATE FOR
MATERIALS USED TO FORM THE SAME
Group Art Unit: 2812

SIR:

Attached hereto for filing are the following papers:

**Confirmation of Attorney and Correspondence Address
Revocation and New Appointment of Power of Attorney (executed)**

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Richard L. Treanor
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